

IMiD 2025

The 25th International Meeting on Information Display
August 19-22, 2025 / BEXCO, BUSAN, KOREA

Session Title:	39. Advanced Manufacturing II
Session Date:	August 21 (Thu.), 2025
Session Time:	16:00-17:45
Session Room:	Room G (314~315)
Session Chair(s):	Prof. Andrews Joseph (Univ. of Wisconsin-Medison, USA) Dr. Seung-Ho Choi (ULVAC, Korea)

[G39-1] [Invited]	16:00-16:25
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Perovskite Quantum Dots Photoresist for Direct Photolithography

Gaoling Yang (Beijing Inst. of Tech., China)

[G39-2] [Invited]	16:25-16:50
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High-Resolution Reverse-Offset Printing-Based Patterning of Thin Films for Metal Oxide TFTs

Asko Sneek, Fei Liu, Patrik Eskelinen, Kim Eiroma, Olli Halonen, Liam Gillan, and Jaakko Leppäniemi (VTT Technical Research Centre of Finland Ltd., Finland)

[G39-3] [Invited]	16:50-17:15
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Development of Display Measurement Technologies for Wide Dynamic Range and VRR Flicker

Kazuyoshi Omata, Katsutoshi Tsurutani, Satoshi Masuda, Mikio Uematsu, Yuzuru Yamamoto, and Yosuke Takebe (Konica Minolta Inc., Japan)

[G39-4]	17:15-17:30
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Sonochemical Treatment of Light Emitting Polymer to Control Viscoelasticity for Inkjet-Printed OLEDs

Dongryul Lee, Seongju Kim, and Sungjune Jung (POSTECH, Korea)

[G39-5]	17:30-17:45
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Film for OLED Displays and Novel Method for Fast Evaluation of Surface Energy on Window Cover Substrate

Do-Young Jeong and Kwan-Young Han (Dankook Univ., Korea)